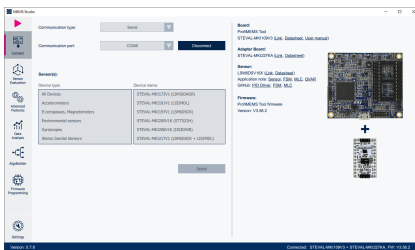
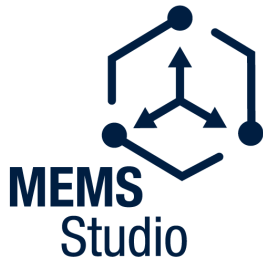


Software solution for MEMS sensors with graphical no-code design of algorithms and development of embedded AI features



Features

- Sensor configuration
 - Easy sensor configuration and evaluation
 - Access to the full sensor register map
 - Interrupt status monitoring
- Sensor data analysis
 - Runtime sensor data visualization charts (line charts, bar graphs, 3D plots, ...)
 - Data logging to .csv file
 - Offline data visualization, data labeling, and editing
 - Fast Fourier transform (FFT) analysis of online and offline data
 - Spectrogram analysis of online and offline data
- Application development
 - Testing of the advanced embedded features (FIFO, pedometer, free fall, ...) in the sensor
 - In-sensor AI design and programming for the finite state machine (FSM), machine learning core (MLC), and intelligent sensor processing unit (ISPU)
 - Visualization and data logging of the output of the embedded software libraries
 - Development of no-code algorithms for data processing in STM32 microcontrollers
- Support for Windows, macOS, and Linux operating systems
- Network updates with automatic notification of new releases

Description

MEMS-Studio is a complete desktop software solution designed to develop embedded AI features, evaluate embedded libraries, analyze data, and design no-code algorithms for the entire portfolio of MEMS sensors. This unique software solution offers a versatile development environment, enabling the evaluation and programming of all MEMS sensors, launching a new generation of solutions that expand the functions of the well-established applications Unico-GUI, Unicleo-GUI, and AlgoBuilder.

MEMS-Studio facilitates the process of implementing proof of concept using a graphical interface without writing code for STM32 microcontrollers. This solution allows configuring sensors and embedded AI (machine learning and neural networks), leveraging on a machine learning core (MLC), neural networks for the ISPU, and finite state machines (FSM). It reuses embedded software libraries, combines multiple functionalities in a single project, and visualizes data in real time using plot and display.

Product summary	
MEMS Studio	MEMS-Studio
Professional MEMS tool	STEVAL-MK1109V3
STM32 Nucleo development boards	STM32 Nucleo
Motion MEMS and environmental sensor expansion boards for STM32 Nucleo	X-NUCLEO-IKS01A3 X-NUCLEO-IKS4A1 X-NUCLEO-IKS02A1
SensorTile.box PRO	STEVAL-MKBOXPRO
STWIN.box	STEVAL-STWINBX1

MEMS-Studio offers the following user experience:

- Sensor evaluation for motion, environmental, and infrared sensors in the MEMS portfolio
- Configuration and testing of in-sensor features such as the finite state machine(FSM), machine learning core (MLC), intelligent sensor processing unit (ISPU)
- Runtime and offline data analysis
- No-code graphical design of algorithms

Revision history

Table 1. Document revision history

Date	Version	Changes
16-Nov-2023	1	Initial release

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